

FORM PTO-1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 134446	SERIAL NO.	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <u>LIST OF ITEMS</u>				Applicant Chayan Mitra, et al		
				Filing Date	Group	
<b>U.S. PATENT DOCUMENTS</b>						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	Filing Date If Appropriate
<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
<b>OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, etc.)</b>						
DAW	C1	Y. Uesugi, et al, "Generation of high heat flux plasmas by high power rf heating in the divertor plasma simulator NAGDIS-II", Vacuum 59 (2000) pp: 24 -34				
{	C2	Y.M. Sung et al, "A review of SiC Static induction transistor development for high frequency power amplifiers", Solid-State Electronics 46 (2002) pp: 605-613				
{	C3	S. Ortolland et al, "Optimisation of a power 4H-SiC SIT device for RF heating applications", Materials Science and Engineering B 61-62 (1999) pp: 411-414				
EXAMINER <i>Douglas Wells</i>				DATE CONSIDERED <i>3 Mar 05</i>		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant						